



REPLY UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER ART UNIT 1763

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
HONGO *et al.*

Confirmation No. 4649

RECEIVED  
SEP 30 2003  
TC 1700

Application No.: 09/815,305

Filed: March 23, 2001

ART UNIT: 1763

Title: PLASMA PROCESSING APPARATUS  
HAVING AN EVACUATING ARRANGEMENT TO  
EVACUATE GAS FROM A GAS-INTRODUCING  
PART OF A PROCESS CHAMBER

Examiner: ALEJANDRO MULERO, L.

\* \* \* \*

September 24, 2003

AMENDMENT AFTER FINAL UNDER 37 C.F.R. § 1.116

Hon. Commissioner of Patents  
Washington, DC 20231

Sir:

Responsive to the Office Action dated June 4, 2003, please amend the above-identified application as follows.